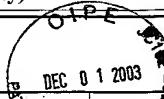


PETITION FOR EXTENSION OF TIME UNDER 37 CFR 1.136(a)
(Large Entity)

Docket No.
86397

In Re Application Of: Satoshi Komiya et al.



Serial No.
10/049,875

Filing Date
February 10, 2002

Examiner
Robert M. Kunemund

Group Art Unit
1765

Invention: SILICON WAFER AND METHOD FOR MANUFACTURE THEREOF, AND METHOD OF
EVALUATION OF SILICON WAFER

TO THE COMMISSIONER FOR PATENTS:

This is a request under the provisions of 37 CFR 1.136(a) to extend the period for filing a response to the Office Action of 06/03/2003 above-identified application.

Date

The requested extension is as follows (check time period desired):

One month Two months Three months Four months Five months
 from: 09/03/2003 until: 12/03/2003
 Date

The fee for the extension of time is \$950 and is to be paid as follows:

- A check in the amount of the fee is enclosed.
- The Director is hereby authorized to charge any fees which may be required, or credit any overpayment, to Deposit Account No. 23-0920
- If an additional extension of time is required, please consider this a petition therefor and charge any additional fees which may be required to Deposit Account No. 23-0920

Signature

Dated:

Gerald T. Shekleton
Welsh & Katz, Ltd.
120 South Riverside Plaza
22nd Floor
Chicago, Illinois 60606
312/655-1500

12/03/2003 MDNTEL 00000027 10049875

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CC:

I certify that this document and fee is being deposited on 11/26/03 with the U.S. Postal Service as first class mail under 37 C.F.R. 1.8 and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Signature of Person Mailing Correspondence

Gerald T. Shekleton

Typed or Printed Name of Person Mailing Correspondence